## Notice of References Cited Application/Control No. 10/673,388 Examiner Art Unit Arnel C. Lavarias Applicant(s)/Patent Under Reexamination SHIH ET AL. Page 1 of 1

## U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	Α	US-5,430,574	07-1995	Tehrani, Mohammad M.	359/378
	В	US-6,263,128	07-2001	Huang, Chi-Hung	385/24
	С	US-2003/0072009	04-2003	Domash et al.	356/519
	D	US-6,721,098	04-2004	Atia, Walid A.	359/578
	Е	US-			
	F	US-			
	G	US-			
	н	US-			
	- 1	US-			
	J	US-			
	К	US-			
	L	US-			
	М	US-			

## FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	NONE				
	0					
	Р					
	Q					
	R					
	s					
	Т					

## **NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)				
	U	E. C. Vail, M. S. Wu, G. S. Li, L. Eng, C. J. Chang-Hasnain, 'GaAs micromachined widely tunable Fabry-Perot filters', Electr. Lett., vol. 31, no. 3, Feb. 2, 1995, pp. 228-229.				
	٧					
	V					
	х					

A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)

Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.